## **INVENTOR INFORMATION**

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Country of Residence: Japan Citizenship Country: Japan

Inventor Two Given Name: Yutaka

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Inventor Three Given Name: Kazuyuki

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Inventor Four Given Name: Toru Family Name: HIRABAYASHI Postal Address Line One:

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CORRESPONDENCE INFORMATION Correspondence Customer Number: 05514

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APPLICATION INFORMATION

Title Line One: EXPOSURE APPARATUS, GAS REPLACEMENT METHOD,
Title Line Two: SEMICONDUCTOR DEVICE MANUFACTURING METHOD,
Title Line Three: SEMICONDUCTOR MANUFACTURING FACTORY AND EXPOSURE

Title Line Four: APPARATUS MAINTENANCE METHOD

Total Drawing Sheets: 14 Formal Drawings?: Yes Application Type: Utility Docket Number: 862.C2167 Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION Representative Customer Number: 5514

PRIOR FOREIGN APPLICATION Foreign Application One: 2000-093686 Filing Date: 03-30-2000

Country: JAPAN

Priority Claimed: Yes

## **INVENTOR INFORMATION (Cont'd)**

Foreign Application Two: 2001-085531 Filing Date: March 23, 2001 Country: JAPAN Priority Claimed: Yes